

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination FETTER ET AL.	
		Examiner Roberts Culbert	Art Unit 1763	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Kohler, Michael; "Etching in Microsystem Technology" Pages 18-22., WILEY-VHC Verlag GmbH, D-69469 Weinheim (Federal Republic of Germany) 1999.
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